

WHAT IS CLAIMED IS:

1. A variable shape mirror comprising:
a frame member having an opening; and
a thin film having a first region including a
5 reflecting plane and a second region of higher rigidity
than the first region disposed in the outer periphery
of the first region, being supported in the opening of
the frame member.
2. A variable shape mirror comprising:
10 a frame member having a first opening and a second
opening;
a first thin film having a reflecting plane,
forming an electrode, and supported in the first
opening of the frame member;
15 a second thin film forming an electrode
electrically conducting with the electrode of the first
thin film, and supported in the second opening of the
frame member;
a substrate bonded to the frame member at a
20 specified interval, and having an electrode at a
position opposite to the electrode of the second thin
film; and
a conductive protrusion disposed on the electrode
of the second thin film or the electrode of the
25 substrate, and having a height higher than the
specified interval.
3. A variable shape mirror comprising:

a frame member having an opening;

a thin film having a reflecting plane supported in the opening of the frame member; and

5 a substrate bonded to the frame member at a specified interval by way of a spacer,

wherein the space between the portion of the frame member having the opening and the substrate is not closed.

4. A manufacturing method of variable shape mirror for bonding a frame member of reflecting plane side of variable shape and a substrate at a specified interval, comprising:

10 applying a photosensitive coating material on either the frame member or the substrate, exposing by using a specified mask, and developing to form a spacer; and

15 bonding the other one of the frame member or the substrate to the spacer, and heating to adhere together.

20 5. A variable shape mirror comprising:

a thin film having a reflecting plane;

a member for supporting the thin film;

means which deforms the thin film; and

25 a sensor formed in part of the thin film for detecting the deformation of the thin film.

6. A variable shape mirror of claim 5, wherein said sensor for detecting the deformation of the thin

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film is a distortion sensor formed on the outer circumference of the thin film, and the outer circumference is greater in film thickness as compared with the central part of the thin film.

5 7. A variable shape mirror comprising:

 a frame member having at least a first opening and a second opening;

 a first thin film having a reflecting plane supported in the first opening of the frame member;

10 a second thin film supported in the second opening of the frame member;

 means which deforms the first thin film and second thin film by applying an equal fluid pressure to the first thin film and second thin film; and

15 a sensor formed in part of the second thin film for detecting the deformation of the second thin film.

 8. A variable shape mirror of claim 7, wherein said frame member is mainly composed of single crystal silicon, said second thin film has a protrusion
20 projecting from the frame member made of a thin film of single crystal silicon, in the peripheral area of the second opening, and said sensor for detecting the deformation of the second thin film is formed on the protrusion.

25 9. A small variable shape mirror applying semiconductor technology comprising:

 a frame member made of single crystal silicon

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having an opening;

a polyimide thin film having a reflecting plane
for covering the opening;

means which deforms the thin film by applying a
5 fluid pressure to the thin film; and

a distortion sensor for detecting the change of
resistance value of resistance pattern formed on the
thin film exposed to the fluid pressure.

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